

Substitute for form 1449A/B/PTO				Complete If Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)				Application Number	Not Yet Assigned 10/814,640
				Filing Date	April 1, 2004
				First Named Inventor	Sukesh Sandhu
				Art Unit	N/A 2825
				Examiner Name	Not Yet Assigned C. Everhart
Sheet	1	of	1	Attorney Docket Number	M4065.0224/P224-A

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
CME	AA*	5,471,364	11/28/1995	Summerfelt, et al.	—
CME	AB*	5,888,870	03/30/1999	Gardner, et al.	—
CME	AC*	5,348,894	09/20/1994	Gnade, et al.	—
CME	AD*	5,674,788	10/07/1997	Wristers, et al.	—
CME	AE*	5,124,174	06/23/1992	Musket, et al.	—

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)				

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
CME	CA*	S. Wolf and R.N. Tauber, "Ion Implantation for VLSI," <i>Silicon Processing for the VLSI Era</i> , Volume 1 – Process Technology, Chapter 9, pages 280-327 (1986)	
CME	CB*	S. Wolf and R.N. Tauber, "Suprem III Models: Ion Implantation," <i>Silicon Processing for the VLSI Era</i> , Volume II, Chapter 9.2.2, pages 658-661 (1986).	

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C. Everhart

9-13-04